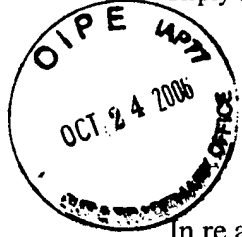


Appl. No. 10/749,775
Amdt. dated October 20, 2006
Reply to Office Action of August 18, 2006

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

DONG-WOO SHIN et al.

Application No.: 10/749,775

Filed: December 30, 2003

For: METHOD FOR FABRICATING
CAPACITOR OF SEMICONDUCTOR
DEVICE

Customer No.: 20350

Confirmation No. 1063

Examiner: Jack S.J. Chen

Technology Center/Art Unit: 2813

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date mailed: October 20, 2006

Sir:

In response to the Office Action mailed August 18, 2006, please enter the following amendments and remarks:

Remarks/Arguments begin on page 2 of this paper.